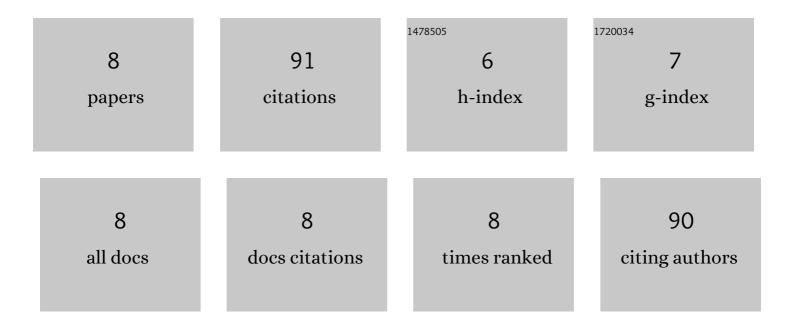
PaweÅ, Knapkiewicz

List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/1100796/publications.pdf Version: 2024-02-01



#	Article	IF	CITATIONS
1	Technological Assessment of MEMS Alkali Vapor Cells for Atomic References. Micromachines, 2019, 10, 25.	2.9	23
2	MEMS caesium vapour cell for european micro-atomic-clock. Procedia Engineering, 2010, 5, 721-724.	1.2	21
3	First-order cancellation of the Cs clock frequency temperature-dependence in Ne-Ar buffer gas mixture. Optics Express, 2011, 19, 3106.	3.4	12
4	Alkali Vapor MEMS Cells Technology toward High-Vacuum Self-Pumping MEMS Cell for Atomic Spectroscopy. Micromachines, 2018, 9, 405.	2.9	11
5	Anodic Bonding of Glass-to-Glass through Magnetron Spattered Nanometric Silicon Layer. Procedia Engineering, 2011, 25, 1629-1632.	1.2	8
6	Ultra-low temperature anodic bonding of silicon and borosilicate glass. Semiconductor Science and Technology, 2019, 34, 035005.	2.0	8
7	Microsensors for Microreaction and Lab-on-a-Chip Applications. , 0, , .		5
8	High-dose radiation sensor with wireless optical detection. Measurement Science and Technology, 2017, 28, 054009.	2.6	3